

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

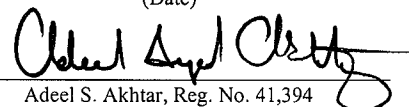
Applicant : Sherman
Appl. No. : 10/683,727
Filed : October 10, 2003
For : SEQUENTIAL CHEMICAL
VAPOR DEPOSITION
Examiner : Kelly M. Stouffer
Group Art Unit : 1762
Confirmation No. : 1627

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November 26, 2007

(Date)



Adeel S. Akhtar, Reg. No. 41,394

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action dated July 26, 2007, Applicants respectfully request consideration of the subsequent remarks.

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.